

Citations for Target : **Cs**

Pub. Year	Authors, Title, Journal Citation and Comments	Citation Numb		
1914	<p>Michl, W. 'Über Die Reichweite der Alpha-Strahlen in Flüssigkeiten' <i>Sitzber. Akad. Wiss. Wien Mathematisch-Naturwissenschaftliche Klasse, 123, 1965-99 (1914)</i></p> <p><i>Comment : R. 5.3 MeV He -> CS₂, H₂O, C₂H₅OH, Ether, Benzene, Anilin, Glycerin, Chloroform</i></p>	<table border="1"> <tr> <td>1914-Mich</td> </tr> <tr> <td>0091</td> </tr> </table>	1914-Mich	0091
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1972	<p>Baily, N. A. Steigerwalt, J. E. Hilbert, J. W. 'Frequency Distributions of Energy Loss by Fast Charged Particles after Passage through Large Thicknesses of Tissue-Equivalent Materials' <i>Health Phys., 22, 497-502 (1972)</i></p> <p><i>Comment : dS. 600 MeV H -> Plastics</i></p>	<table border="1"> <tr> <td>1972-Bail</td> </tr> <tr> <td>0667</td> </tr> </table>	1972-Bail	0667
1972-Bail				
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1972	<p>Walsh, P. J. Pendergrass, F. 'Energy Loss of Alpha Particles in Tissue Equivalent Plastic' <i>Health Phys., 23, 701-04 (1972)</i></p> <p><i>Comment : S. 1-5.5 MeV He -> Tef (Plastic)</i></p>	<table border="1"> <tr> <td>1972-Wals</td> </tr> <tr> <td>0691</td> </tr> </table>	1972-Wals	0691
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1976	<p>Hartemann, P. Marizot, M. 'Ion Implantation in Piezoelectric Substrates' <i>Ion Implantation in Semiconductors, Ed. by F. Chernow, J. A. Borders, D. K. Brice, 257-264 (1976)</i></p> <p><i>Comment : R. 100 keV He, Li, Be -> Piezoelectric Substrates</i></p>	<table border="1"> <tr> <td>1976-Hart</td> </tr> <tr> <td>1067</td> </tr> </table>	1976-Hart	1067
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1982	<p>Kreussler, S. Varelas, C. Sizmann, R. 'Electronic Stopping Power and Effective Charge of 50- to 230 keV D and He in C, Al, Au and Cs' <i>Phys. Rev. B, 26 (11), 6099-6103 (1982)</i></p> <p><i>Comment : S. D, He (50-230 keV) -> C, Al, Cs, Au</i></p>	<table border="1"> <tr> <td>1982-Kreu</td> </tr> <tr> <td>1416</td> </tr> </table>	1982-Kreu	1416
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